

**N THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)
Setsuo <b>NAKAJIMA</b>	) Group Art Unit: 2814
Serial No. 10/752,993	) Examiner: Shrinivas H. Rao
Filed: January 8, 2004	) Confirmation No. 6484
For: METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE	) October 27, 2008

**REQUEST FOR RECONSIDERATION**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action mailed July 25, 2008, Applicant respectfully requests reconsideration of the present application.

**REMARKS**

The Office Action of July 25, 2008 was received and carefully reviewed. Claims 1-4, 6-10, 12-16, 18-22, 24-28, 30-34 and 36-100 were pending prior to the instant amendment. Reconsideration and withdrawal of the currently pending rejections are requested for the reasons advanced in detail below.

The Examiner's indication of allowable subject matter with respect to claims 1-4, 6-10, 12-16, 18-22, 24-28, 30-34, 36-54 and 99-100 is gratefully acknowledged. However, for the reasons advanced herein, it is respectfully submitted that all of the pending claims are allowable.

Claims 55-91 were rejected under 35 U.S.C. §103(a) as being unpatentable over Nitta et al. (US. Patent No. 6,304,329, hereinafter Nitta) in view of Sasaki et al. (U.S. Patent No. 5,213,654, hereinafter Sasaki) and Mitnaga et al. (U.S. Patent No. 5,808,321, hereinafter